

<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary) <div style="border: 1px solid black; border-radius: 50%; width: 100px; height: 100px; display: flex; align-items: center; justify-content: center; margin: 10px auto;"> <div style="writing-mode: vertical-rl; transform: rotate(180deg);">PATENT &amp; TRADEMARK OFFICE</div> <div style="text-align: center;"> <b>MAR 03 2005</b>  <small>106</small> </div> </div>				Docket Number (Optional) <b>YPL-0076</b>		Application Number <b>10/763,694</b>		
				Applicant(s) <b>Hyeong-sop SHIM, et al.</b>				
				Filing Date <b>1/23/2004</b>		Group Art Unit <b>1749 1631</b>		
<b>U.S. PATENT DOCUMENTS</b>								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
CS		6,300,063	10/9/2001	Lipshutz et al.	435	6	5/8/1997	
CS		6,027,880	2/22/2000	Cronin et al.	435	6	10/10/1995	
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<b>FOREIGN PATENT DOCUMENTS</b>								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, Etc.)								
CS		Office Action of Korean Patent Office regarding corresponding Korean Patent Applicatin No. 10-2003-0005025, dated 12/23/2004						
EXAMINER				DATE CONSIDERED				
/Carolyn Smith/				02/27/2007				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

APR 29 2004



Docket Number (Optional)

YPL-0076

Application Number

10/763,694

Applicant(s)

Hyeong-sop Shim, et al.

Filing Date

1-23-2004

Group Art Unit

1631

~~NTA~~

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
CS		2003-0020232	3-8-2003	KOREA			abstract	
CS		2003-0072709	9-19-2003	KOREA			abstract	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

CS		"Applied Logistic Regression"; Second Edition; Authors: David W. Hosmer and Stanley Lemeshow; Wiley Series in Probability and Statistics; Pgs. 1-30, 2000.

EXAMINER /Carolyn Smith/

DATE CONSIDERED

02/27/2007

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